## Notice of References Cited Application/Control No. 10/099,717 Examiner Cheukfan Lee Applicant(s)/Patent Under Reexamination KOSHIMIZU ET AL. Page 1 of 1

## **U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-6,323,967	11-2001	Fujinawa, Nobuhiro	358/484
	В	US-6,660,987	12-2003	Koshimizu, Masato	250/208.1
	С	US-6,796,502	09-2004	Nogami et al.	235/454
	D	US-6,532,085	03-2003	Fujinawa, Nobuhiro	358/475
	Ε	US-6,474,836	11-2002	Konagaya, Tatsuya	362/231
	F	US-6,806,981	10-2004	Konno, Masaaki	358/505
	G	US-6,791,721	09-2004	Konogaya et al.	358/474
	Н	US-6,493,061	12-2002	Arita et al.	355/41
	1	US-6,734,997	05-2004	Lin, Chin-Yuan	358/487
	J	US-6,765,701	07-2004	Yang et al.	358/487
	к	US-5,969,372	10-1999	Stavely et al.	250/559.42
	L	US-6,437,358	08-2002	Potucek et al.	250/559.45
	м	US-2002/0168116 A1	11-2002	Takayama et al.	382/275

## **FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
,	N					
	0	·				
	Р					
	Q					
	R					·
	s					
	Т					

## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	w	
	×	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.